PTO-1449 REPRODUCED INFORMATION DISCLOSURE CITATION IN AN APPLICATION	ATTORNEY DOCKET NO. 0100.1361-027		APPLICATION NO. 10/750,547		
	FIRST NAMED INVENTOR FILING DATE Peter W. Gaudet 12/31/03				
October 25, 2004	EXAMINER N/A	CONF	IRMATION NO.	GROUP 3744	
PATERTIES					

		U.S	. PATENT DOCUMENTS	
EXAM- INER INI- TIAL	REF. NO.	DOCUMENT NUMBER Number-Kind Code (if known)	ISSUE DATE / PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT
M	AA	4,953,359	10-19-1982	Milner
	AB	4,361,418	11-30-1982	Tscheppe
	AC	4,412,851	11-01-1983	Laine
	AD	4,438,632	03-27-1984	Lessard, et al.
	ΑĒ	4,546,613	10-15-1985	Eacobacci, et al.
	AF	4,602,642	07-29-1986	O'Hara, et al.
	AG	4,614,093	09-30-1986	Bachler, et al.
	AН	4,633,672	01-06-1987	Persem, et al.
	Αl	4,667,477	05-26-1987	Matsuda, et al.
	AJ	4,679,401	07-14-1987	Lessard, et al.
	AK	4,688,261	08-18-1987	Killoway, et al.
	AA2	4,724,677	02-16-1988	Foster
	AB2	4,757,689	07-19-1988	Bachler, et al.
	AC2	4,829,774	05-16-1989	Wassibauer, et al.
	AD2	4,918,930	04-24-1990	Gaudet, et al.
	AE2	4,926,648	05-22-1990	Okumura, et al.
	AF2	4,953,359	09-04-1990	Forth, et al.
	AG2	4,873,833	10-17-1989	Pfeiffer, et al.
	AH2	4,958,499	09-25-1990	Haefner, et al.
	Al2	5,060,263	10-22-1991	Bosen, et al.
	AJ2	5,062,271	11-05-1991	Okumura, et al.
	AK2	5,062,771	11-05-1991	Satou, et al.
	AA3	5,157,928	10-27-1992	Gaudet, et al.
	AB3	5,222,135	06-22-1993	Hardy, et al.
1	AC3	5,265,431	11-30-1993	Gaudet, et al.
M	AD3	5,323,465	06-21-1994	Avarne

EXAMINER MICAWA DATE CONSIDERED 3/70/06

PTO-1449 REPRODUCED	ATTORNEY DOCKET NO. 0100.1361-027 APPLICATION 10/750,547			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	FIRST NAMED INVENTOR FILING DATE Peter W. Gaudet 12/31/03			
October 25, 2004 (Use several sheets if necessary)	EXAMINER N/A	CONFI 5579	RMATION NO.	GROUP 3744

U.S. PATENT DOCUMENTS							
EXAM- INER INI- TIAL	REF. NO.	DOCUMENT NUMBER Number-Kind Code (if known)	ISSUE DATE / PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT			
MJ	AE3	5,343,708	09-06-1994	Gaudet, et al.			
	AF3	5,443,368	08-22-1995	Weeks, et al.			
	AG3	5,517,823	05-21-1996	Andeen, et al.			
	АН3	5,542,828	08-06-1996	Grenci, et al.			
	Al3	5,575,853	11-19-1996	Arami, et al.			
	AJ3	5,582,017	12-10-1996	Noji, et al.			
	AK3	5,678,759	10-21-1997	Grenci, et al.			
	AA4	6,022,195	02-08-2000	Gaudet, et al.			
	AB4	5,348,448	09-20-1994	Ikemoto, et al.			
	AC4	5,398,543	03-21-1995	Fukushima, et al.			
	AD4	4,735,084	04-05-1998	Fruzzetti			
	AE4	4,709,579	12-01-1987	Parker, et al.			
	AF4	4,919,599	04-24-1990	Reich, et al.			
	AG4	5,114,316	05-19-1992	Shimizu			
	AH4	5,209,631	05-11-1993	Bernhardt			
m	Al4	3,832,084	08-27-1974	Maurice			
				1			

·				
EXAMINER	MUI	nal	DATE CONSIDERED	3/20/06
@PFDcsktop\::ODM	1A/MHODMA/HBSF	R05;iManage;498412;1		

PTO-1449 REPRODUCED			PLICATION NO. /750,547		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION October 25, 2004 (Use several sheets if necessary)	FIRST NAMED INVENTOR FILING DATE Peter W. Gaudet 12/31/03				
	EXAMINER N/A	CONF 5579	IRMATION NO.	GROUP 3744	

		DOCUMENT NUMBER Country Code-Number-Kind Code (if known)	DATE MM-DD-YYYY	NAME OF PATENTEE OR APPLICANT OF CITED DOCUMENT	TRANS YES	LATION NO
mi	AL	CH 652 804 A5	11-29-1985	Balzers Aktiengesellschaft		1
1	AM	GB 2 065 782	07-01-1981	Leybold-Heraeus GmbH		
	AN	JP 2-204696	08-1990	Shimazu Corporation	х	
	AO	JP 403107599	05-07-1991	NTN Corp.		х
1.	AP	JP 403182698	08-08-1991	Seiko Seiki Co. Ltd.		x
mi	AQ	JP 4-164188	06-1992	Omato, et al.		x
• •	AL2					
	AM2					
	AN2					
	AO2					
•	AP2					
•	AQ2				_, -	
	AL3					
···	АМ3					
	AN3					
	AO3					
	AP3					
	AQ3					
	AL4					
	AM4					
	AN4					
	A04					
	AP4					
	AQ4					

•				
EXAMINER	Mellow	DATE CONSIDERED	3/20/06	
@PFDesktop\::ODM	VMHODMA/HBSR05;iManage;498412;1			

PTO-1449 REPRODUCED	1		LICATION NO. 1750,547		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	FIRST NAMED INVENTOR FILING DATE Peter W. Gaudet 12/31/03				
October 25, 2004	EXAMINER	CONFI	RMATION NO.	GROUP	
(Use several sheets if necessary)	N/A	5579		3744	

		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
ms	AR	Sheats and Halverson, "State of the Art Microprocessor Technology Applied to Cryogenic Temperature Readout and Control," Cryogenic Conference, San Diego, CA 1981, pp. 1183-1188.
	AS	Finley, "Automatic regeneration of multiple cryopumps," <u>J. Vac. Sci. Technology</u> , A4(3), May/June 1986, pp. 310-313.
	AT	Temescal product description, September 1982.
	ΑŲ	Peterson, John F., "Cryopump Regeneration for Optimized Uptime," Solid State Technology, April 1986, pp. 199-201.
	AV	Longsworth, R.C., et al., "Cryopump regeneration studies," <u>J. Vac. Sci. Technology</u> , 21(4), Nov./Dec. 1982, pp. 1022-1027.
	AV	Peterson, John F. et al., "Vacuum Pump Technology; A Short Course on Theory and Operations," Solid State Technology, January 1982, pp. 104-110.
	AX	Sievert, Reinhard, "Regenerating Refrigerator-Cryopumps Cooled," Solid State Technology, May 1986, pp. 90-92.
	AY	Singer, Peter H., "Update on Cryogenic Pumps," Semiconductor International, October 1982, pp. 89-99.
	AZ	Ehmann, John, "Regeneration of High-Vacuum Cryopumps," Solid State Technology, April 1982, pp. 235-239.
	AR2	Brown, Thomas, et al., "Microcomputer Applications in the Space Simulation Laboratory," <u>Proceedings - Institute of Environmental Sciences</u> , 1983, pp. 179-188.
	AS2	Sheats, David C., et al., "Microprocessor-Based Cryopump Controller," Cryogenic Conference, August 15-19, 1983.
	AT2	Pamphlet, "Cryopumping," CTI-Cryogenics, 1986, 4 pages.
·	AU2	Brochure, "ATP 1500M, Magnetically Levitated Turbomolecular Pump," Alcatel CIT Industries Division, April 1992, pp. 1-4.
My	AV2	O'Hanlon, John F., A User's Guide to Vacuum Technology, Second Edition, Chapter 11, "Turbomolecular Pumps," 1989, pp. 181-195.

EXAMINER	MO)	(no)	DATE CONSIDERED	3/20/	06

PTO-1449 REPRODUCED	ATTORNEY DOCKET NO. 0100.1361-027 APPLICATION NO. 10/750,547 FIRST NAMED INVENTOR FILING DATE 12/31/03			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION			-	
October 25, 2004 (Use several sheets if necessary)	EXAMINER N/A	CONFI 5579	RMATION NO.	GROUP 3744

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
M)Î	AW2	O'Hanlon, John F., <u>A User's Guide to Vacuum Technology</u> , Second Edition, Section 19.2, "Turbomolecular-Pumped Systems," 1989, pp. 361-368.				
M	AX2	O'Hanlon, John F., A User's Guide to Vacuum Technology, Second Edition, Section 20.2.2, "Turbomolecular Pumps," 1989, pp. 393-394.				
		•				
		•				

	5.1.1			
EXAMINER	Mernus	DATE CONSIDERED	3/20/00	-